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By:

Christopher Shull

Date:

April 7, 2003

**PATENT
Box RCE**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re:

Nanning J. Arfsten, *et al.*

: Group Art Unit 1775

Conf. No.: 8672

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Appln. No. 09/437,948

: Examiner: J. McNeil

Filed: November 10, 1999

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For: NIOBIUM OXIDE-BASED LAYERS
FOR THIN FILM OPTICAL
COATINGS AND PROCESSES FOR
PRODUCING THE SAME

: Attorney Docket

: No. 275-3US

:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

It is requested that the references listed on the attached Information Disclosure Citation Form PTO/SB/08A be considered by the Patent Examiner in connection with the above-identified application and be made of record therein.

Independent consideration and acknowledgment of the listed references are respectfully requested.

Respectfully submitted,

NANNING J. ARFSTEN, ET AL.

April 7, 2003
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